

Ion source diagnostics and ion beam diagnostics for ECRIS

- intensity
- profile
- emittance
- space charge compensation
- light/X-rays coming from plasma
- ...

Intensity measurements

- Load on extraction PS
- Faraday cup
- Beam transformer
- Flying wire
- Charge state distribution by spectrometer
- Charge state distribution by TOF
- ...

Profile measurement

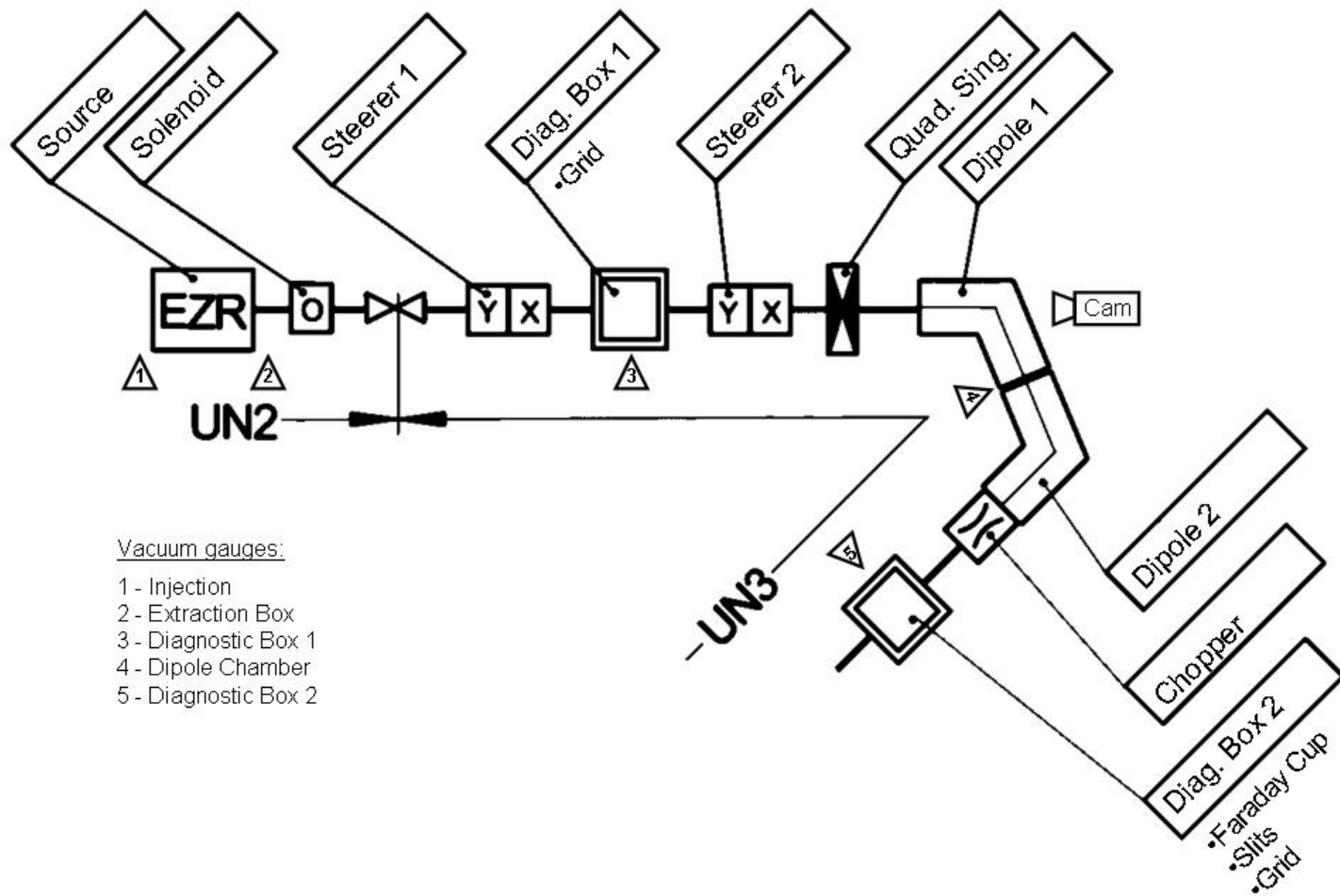
- Viewing targets with BaF, ... provide real profiles, confirmed by μ -FC arrays.
- Lifetime of viewing targets is limited.
- A lot of secondary electrons will influence the ion beam.

Emittance measurement

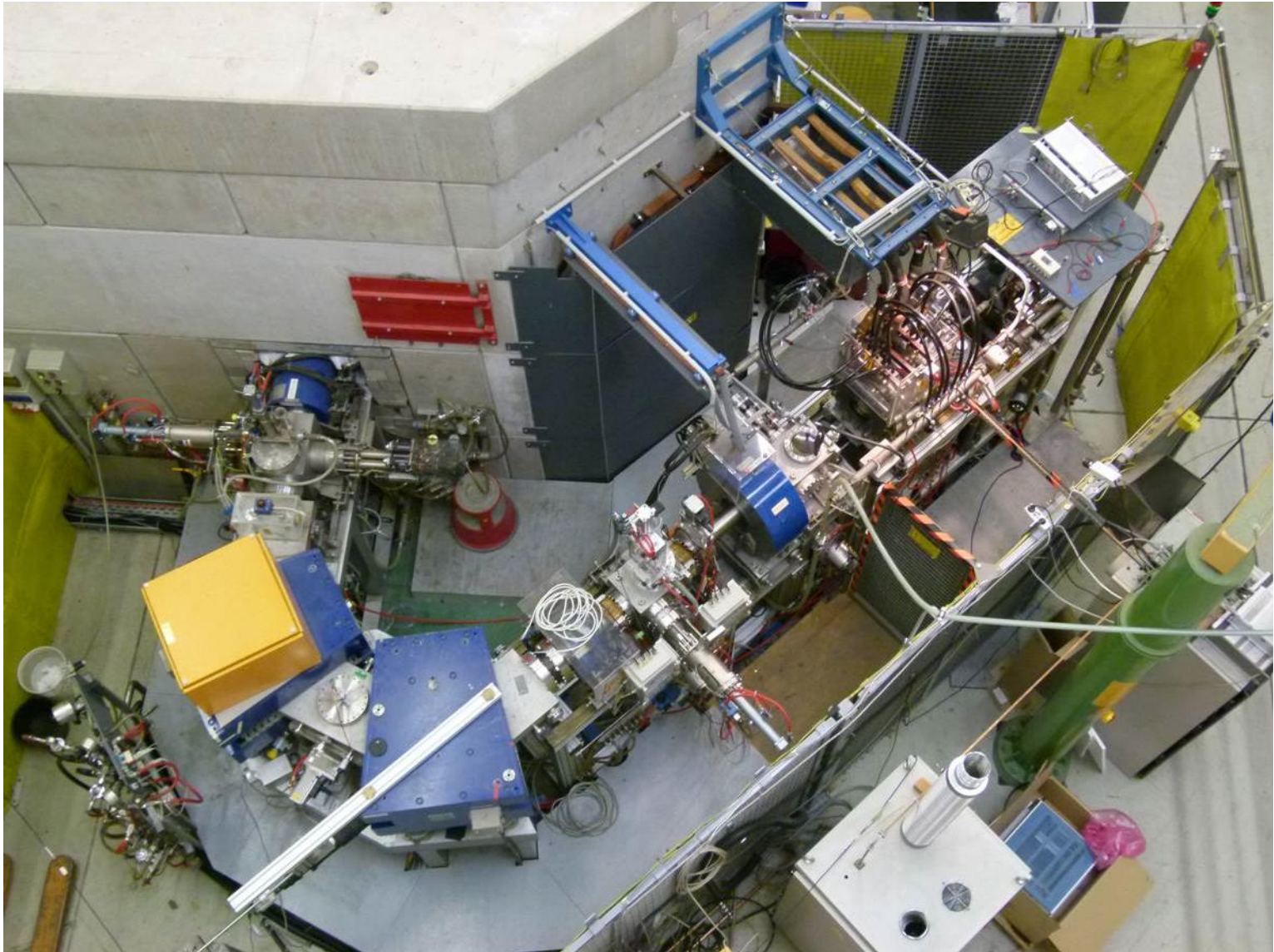
- Allison scanner not suitable for ECRIS. Because of integration in real space.
- Pepper pot gives 4D information, but software is still missing.
- Hardware problems (for our pepper pot, sensitivity of the CCD) still exist.
- Be aware: a huge amount of electrons will influence the measurement in both cases.

Space charge compensation

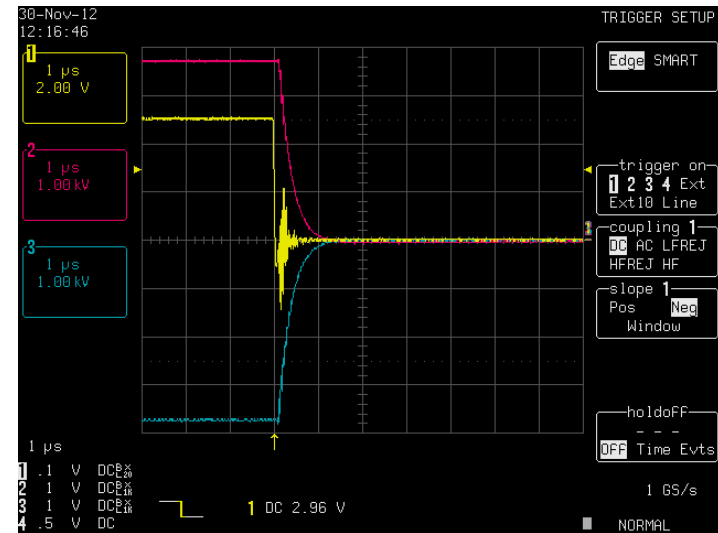
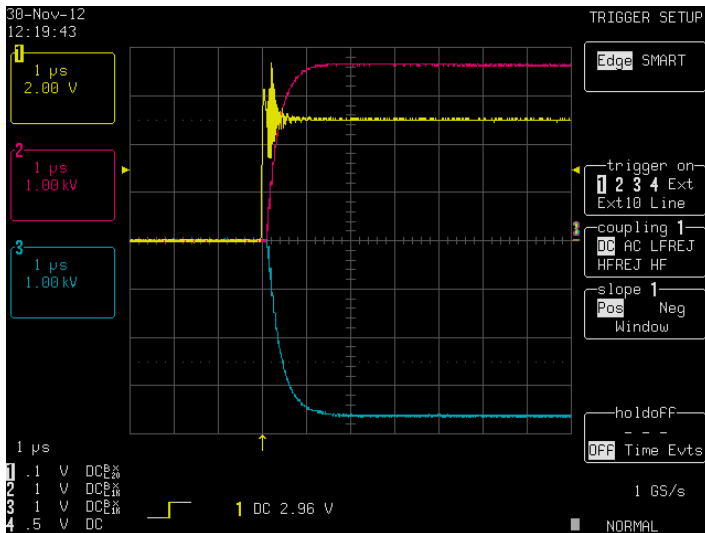
- biased wires
 - positive bias: electrons will be removed from the beam as long as the space charge potential is less positive than the applied voltage.
- biased tube/ring
 - positive bias: electrons will be removed from the beam as long as the space charge potential is less positive than the applied voltage.
 - negative bias: electrons will be repelled from regions with negative potential.
- transversal field
 - The beam will be dumped (completely destroyed) as long as the field is present.



- Vacuum gauges:
- 1 - Injection
 - 2 - Extraction Box
 - 3 - Diagnostic Box 1
 - 4 - Dipole Chamber
 - 5 - Diagnostic Box 2



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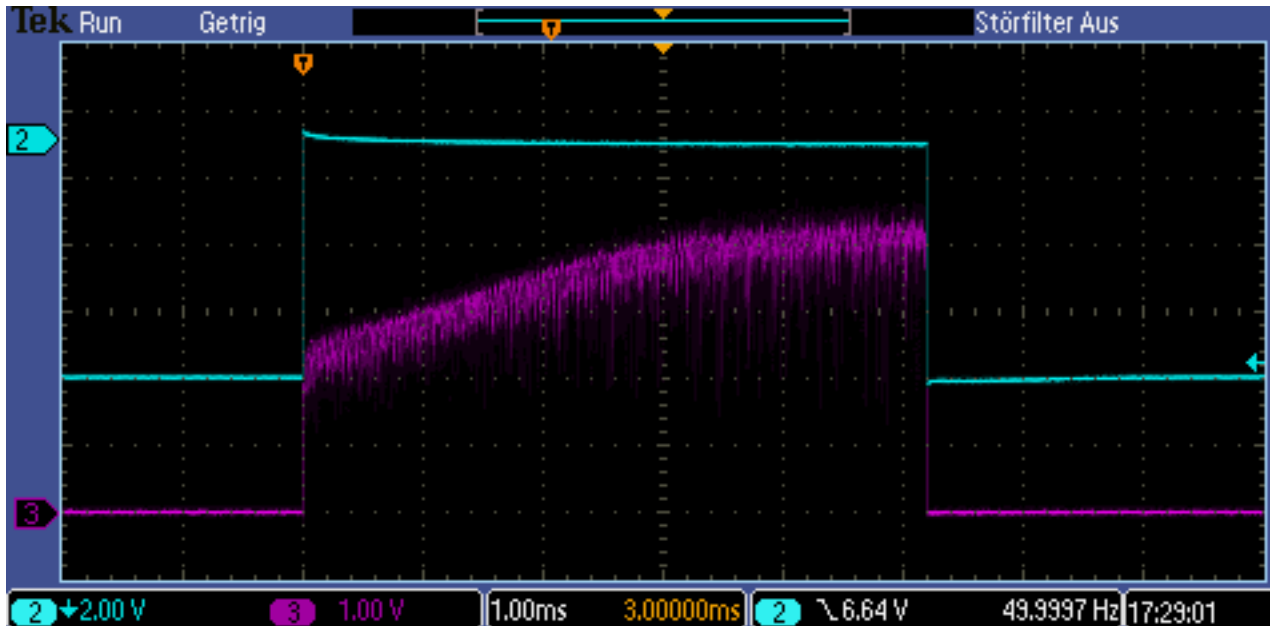


chopper signals:

yellow timing
red positive voltage
blue negative voltage

action:

voltage on \rightarrow no beam
voltage off \rightarrow beam on,
space charge compensation starts to
build up.



wire grid out →

3.5 ms compensation
build up time.

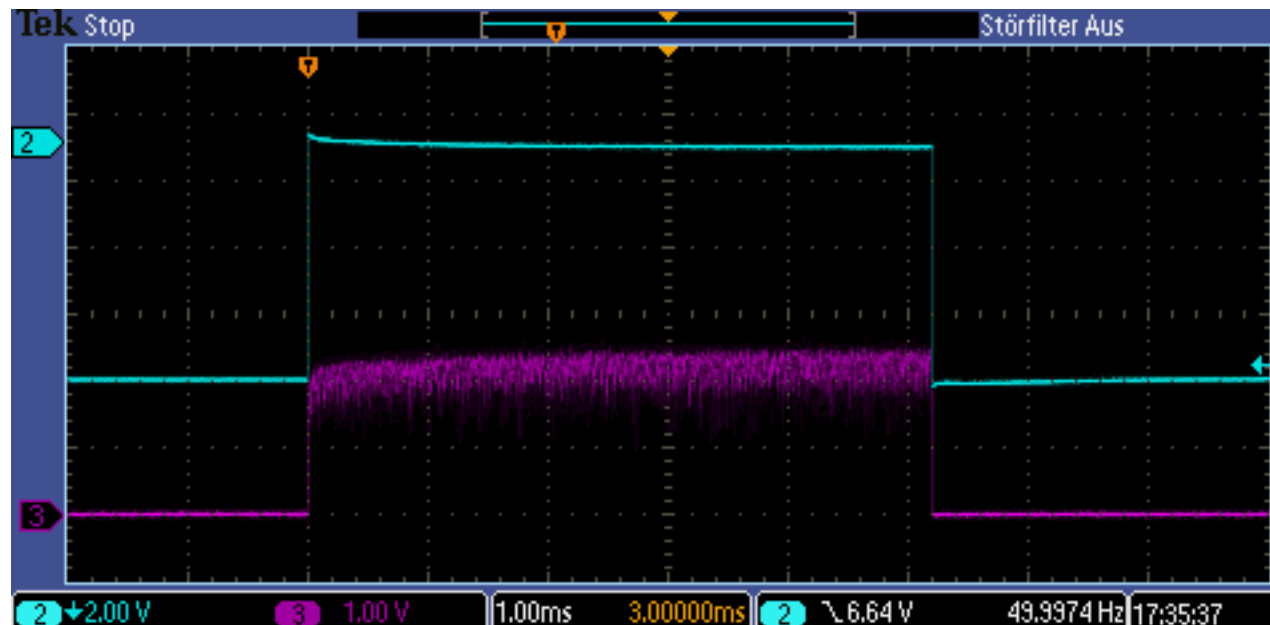
*He⁺ ion beam 5keV,
p ≈ 10⁻⁷ mbar*

signal: Faraday cup

*blue: timing
(chopper off)*

*magenta: 10kΩ
(100 μA/div)*

horizontal: 1ms/div



wire grid in →

0.1 ms compensation
build up time

- View through the extraction hole into plasma.
 - suitable for oven control.
 - to check the action of screening, provided by the accel-decel extraction system.



Thank you for your attention!